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January 13, 2005

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Luetzen, et al.

Docket No.:

**INF-115** 

Serial No:

10/721,225

Art Unit:

1765

Date Filed:

November 26, 2003

Title:

Method and Structures for Increasing the Structure Density and the Storage

Capacitance in a Semiconductor Wafer

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Respectfully submitted,

Natalie Swider Legal Assistant

Confirmation Respectfully Requested

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#### POWER OF ATTORNEY

POWER OF ATTORNEY	ATTORNEY DOCKET NO.	INF-115
FOR PATENT APPLICATION		

As a below named inventor for the PATENT APPLICATION entitled:

Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

Application Serial No. 10/721,225, filed on November 26, 2003, I hereby appoint the following attorneys listed below to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

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POWER OF ATTORNEY FOR PATENT APPLICATION	ATTORNEY DOCKET NO. INF-115
As a below named inventor for the PATENT AP	PLICATION entitled:
Method and Structures for Increasing the Struc Semiconductor Wafer	cture Density and the Storage Capacitance in
Application Serial No. 10/721,225, filed on Novattomeys listed below to prosecute this applica Trademark Office connected therewith.	vember 26, 2003, I hereby appoint the following tion and transact all business in the Patent are
All practitioners at Customer No.	48154
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As a below named inventor for the PATENT APPI	LICATION entitled:	
Method and Structures for Increasing the Structu Semiconductor Wafer	me Density and the Storage Capacitance	in a
Application Serial No. 10/721,225, filed on Nover attorneys listed below to prosecute this application Trademark Office connected therewith.	mber 26, 2003, I hereby appoint the follow on and transact all business in the Patent	wing an
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FOR PATENT APPLICATION		
I FUR PAIENT APPLICATION		

As a below named inventor for the PATENT APPLICATION entitled:

Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

Application Serial No. 10/721,225, filed on November 26, 2003, I hereby appoint the following afformeys listed below to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

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FOR PATENT APPLICATION			

As a below named inventor for the PATENT APPLICATION entitled:

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